Midinfrared photoreflectance study of InAs-rich InAsSb and GaInAsPSb indicating negligible bowing for the spin orbit splitting energy

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The authors report on midinfrared photoreflectance measurements of the band gap (E_0) and spin-orbit splitting energies (Δ_0) in InAs-rich InAsSb and GaInAsPSb samples for varying antimony contents $\leq 22.5\%$. The E_0 behavior as a function of Sb content is consistent with the literature value bowing parameter of ~ 670 meV. However, Δ_0 does not exhibit the positive bowing of +1170 meV quoted in the literature: rather, a best fit to their data tentatively suggests a negative bowing of -225 meV. This result is likely to have strong impact due to the importance of the Δ_0 parameter in governing InAsSb-based device performance. © 2007 American Institute of Physics. [DOI: 10.1063/1.2728752]

Recent interest in developing midinfrared (MIR, $2-5 \ \mu m$) light emitters and detectors has been driven by the wide range of potential applications in this spectral region.¹ As a result of high Auger recombination coefficients, MIR semiconductors exhibit low quantum efficiencies and devices often have to operate below room temperature.² The Auger recombination rates are sensitive to the fundamental band gap energy E_0 and [in the case of the conduction, heavy-hole, spin split-off hole, heavy-hole (CHSH) process] the spin-orbit splitting energy Δ_0 .³ Therefore, in order to evaluate losses by these nonradiative recombination paths, a good knowledge of both E_0 and Δ_0 is essential.

The $InAs_{1-x}Sb_x$ alloy plays a particularly important role in many MIR devices.^{2,4,5} As a ternary alloy it is possible to define the compositional dependence of a parameter T (such as E_0 or Δ_0) using $T = xB_1 + (1-x)B_2 - x(1-x)C$, where B_1 is the binary end-point InSb value, B_2 the InAs value, and C a bowing parameter which describes any deviation from the virtual crystal approximation.⁶ A range of studies of E_0 in InAs_{1-x}Sb_x indicates that C lies between 570–690 meV⁷⁻⁹ and the review of Vurgaftman *et al.* recommends using $C(E_0) = +670 \text{ meV.}^{10}$ There is less information in the literature, and some uncertainty, regarding Δ_0 in InAs_{1-x}Sb_x. In 1972 Berolo and Woolley¹¹ published the first and only measured values for Δ_0 , using electroreflectance on samples grown by the horizontal Bridgman technique.¹² Although no actual spectra were published, they reported a bowing parameter of $C(\Delta_0) = +1170$ meV, by far the largest of any III-V ternary alloy.¹⁰ They attributed this, and similar trends they observed in other ternary alloys,¹¹ to interband mixing effects and disordering within the lattice.¹³ Subsequently, several authors have suggested that such bowing $[C(\Delta_0)]$ >0] is not predicted by theory for ordered systems: Siggia remarks that his calculations for Δ_0 in InAs_{1-x}Sb_x cannot demonstrate the bowing claimed by Berolo and Woolley¹¹ unless his Kane-formula conduction band effective mass values are doubled, but that would then disagree with experimental measurements of the effective mass.¹⁴ After several experiments reported $C(\Delta_0) < 0$ in epitaxial quaternary alloys,¹⁵⁻¹⁷ Wei and Zunger¹⁸ conducted self-consistent electronic-structure calculations for ordered ternary alloys which predicted $C(\Delta_0) < 0$. They noted that an unphysically large interband mixing coefficient of 48% would be required to explain the positive bowing in $InAs_{1-x}Sb_x$ and concluded instead that sample inhomogeneity in Ref. 11 was a more likely cause, with a recommendation to conduct new measurements on homogeneous epitaxial samples. Here, we use MIR photoreflectance (PR) spectroscopy to measure the E_0 and $E_0 + \Delta_0$ transitions in high-quality epitaxial InAs_{1-x}Sb_x samples (of thickness 500 nm, with 300 nm InAs buffer layers) grown by molecular beam epitaxy (MBE), on *n*-InAs substrates, with Sb molar fractions of $0 \le x \le 22.5\%$ determined from x-ray diffraction measurements. In all these samples the epilayers are thicker than the determined critical thicknesses (~ 100 nm), indicating that they are likely to be fully relaxed. We also study the PR of two InAsSb-rich, $Ga_zIn_{1-z}As_{1-v-x}P_vSb_x$ samples of thickness ~1.5 μ m, grown by liquid phase epitaxy (LPE), lattice matched to GaSb substrates. These two pentenary alloys (s922 and s923) were determined to have the compositions $Ga_{0.04}In_{0.96}As_{0.83}P_{0.04}Sb_{0.13}$ and $Ga_{0.07}In_{0.93}As_{0.82}P_{0.03}Sb_{0.15}$, respectively.

The PR was done using a 0.32 m monochromator with gratings blazed at either 1.5 or 5.0 μ m to disperse the probe beam from a tungsten filament bulb, and detected by a 77 K InSb photodiode. The sample reflectivity was modulated with a mechanically chopped (883 Hz) HeNe laser (633 nm, \sim 10 mW). In some samples strong background signals necessitated a reduction of the laser power with neutral density filters.

Figure 1 shows the PR of all our samples at 10 K, with the exception of the 16.0% Sb sample, which exhibited a particularly weak PR signal: here a better signal to noise ratio was achieved at 50 K. This decreases its band gap by

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FIG. 1. Low temperature PR of the E_0 and $E_0+\Delta_0$ features in the seven InAsSb samples, as well as two pentenary GaInAsPSb samples, *s*922 and *s*923. For clarity, spectra are vertically offset according to Sb content shown next to each spectrum (base lines indicated by ticks on vertical axis). For the weakest observed $E_0+\Delta_0$ feature, data points with a least-squares fit are shown (see text).

only ~ 2 meV which we account for later. PR features from the E_0 transition in each sample are clearly visible, displaying a strong redshift with increasing antimony concentration. The corresponding transition energies were determined precisely by fitting all the PR features with third-derivative functional forms (TDFFs).¹⁹ In the case of the E_0 feature, the resulting fitted energies agree to within a few meV of the peak positions of the corresponding 10 K photoluminescence (PL) spectra (not shown). We find that the sample with the highest Sb content (22.5%) has $E_0 = 261 \pm 5 \text{ meV}$ (4.75 μ m), which represents the longest wavelength PR signal measured so far using grating spectroscopy.^{20,21} The PR signal generally gradually decreases with increasing Sb content (see multiplication factors in Fig. 1). However, the E_0 PR feature remains quite sharp, with width ranging from 7 to just 23 meV, indicating high-quality epilayers and enabling a more precise determination of E_0 than is possible from the corresponding 10 K PL peaks (widths ranging from 20 to 32 meV).

For all but the highest two Sb concentrations we also observe a PR feature in the 800 meV near-infrared region, which we believe is associated with the $E_0+\Delta_0$ transition. Again, the energies of these features were determined precisely by fitting with a TDFF, as shown in the example in Fig. 1 for the 15.5% Sb sample. For InAs_{1-x}Sb_x samples grown on InAs there is a possibility that these features may be partially, or entirely, due to the $E_0+\Delta_0$ transition of the substrate layer, rather than the epilayer. However, we are confident that this is not the case here since the penetration depth of the HeNe laser through the 500 nm thick InAs_{1-x}Sb_x epilayers is ~100 nm at 10 K, making modulation of the



FIG. 2. Variation of the fundamental band gap E_0 (a) and spin-orbit splitting energy Δ_0 (b) at 10 K as a function of Sb composition for InAs_{1-x}Sb_x as determined from the PR spectra of Fig. 1. Estimated uncertainties due to the fitting process are smaller than the symbols used in both graphs. The lines and curves are explained in the text.

nificant PR signals at 10 K near the InAs band gap $(E_0 \sim 415 \text{ meV})$, we would not expect to observe a corresponding $E_0 + \Delta_0$ substrate signal since the penetration depth of the probe beam in InAs_{1-x}Sb_x at 800 meV is less than half of that at 400 meV.

The PR spectra of the two InAsSb-rich $Ga_zIn_{1-z}As_{1-v-x}P_vSb_x$ LPE samples (s922 and s923) also show features near 800 meV in Fig. 1, similar to those of $InAs_{1-x}Sb_x$. Since these were grown on GaSb and not on InAs, such features cannot arise from $E_0 + \Delta_0$ substrate transitions. On the other hand, at 10 K GaSb has a fundamental band gap of 812 meV.¹⁰ However, this is more than 15 meV above the fitted energies obtained for the PR of s922 and s923 in this spectral region. This, combined with the fact that the pentenary epilayers are $\sim 1.5 \ \mu m$ thick in these LPE samples (over ten times the penetration depth of the HeNe laser), rules out the possibility that the observed features near 800 meV arise from E_0 substrate signals.

Figure 2(a) shows the 10 K values for E_0 obtained from the TDFF fits of the $InAs_{1-x}Sb_x$ PR spectra in Fig. 1, as a function of Sb content. The straight line shows a linear interpolation (no bowing) between the InAs and InSb end points, while the curve represents the accepted bowing of C = +670 meV.¹⁰ Our values for E_0 tend to lie slightly above the accepted bowing curve, by ~20 meV, similar to Ref. 9 and other studies on InAsSb samples rich in InAs.^{7,8} This may be due to a slight overestimation of the Sb concentrations due to our assumption of full relaxation.

Figure 2(b) shows our 10 K Δ_0 results for the InAs_{1-x}Sb_x samples where an $E_0 + \Delta_0$ PR feature was observed. It is clear that Δ_0 *does not* exhibit the strong, positive bowing claimed by Berolo and Woolley¹¹ and quoted by Vurgaftmann *et al.* [C = +1170 meV, the curve in Fig. 2(b)]. Our results show no positive bowing, and, if anything, may show a slightly opposing trend with a fit of the data in Fig. 2(b) (not shown) giving $C(\Delta_0) = -225$ meV. Although a negative bowing has been predicted by Wei and Zunger for ordered ternary alloys,¹⁸ our result provides only tentative supporting evidence of this due to the range of Sb content studied. However, our work on high-quality, epitaxial MBE InAs_{1-x}Sb_x

substrate unlikely. Furthermore, since we do not observe sig-Downloaded 11 Mar 2008 to 194.80.32.9. Redistribution subject to AIP license or copyright; see http://apl.aip.org/apl/copyright.jsp samples supports the contention of Ref. 18 that the strong, positive Δ_0 bowing of Ref. 11 may indeed be due to the inhomogeneity in their Bridgman-grown samples.

A similar TDFF fitting analysis of the PR spectra of the two $Ga_zIn_{1-z}As_{1-v-x}P_vSb_x$ LPE samples in Fig. 1 (s922 and s923) gives Δ_0 values of 453±5 and 460±5 meV, respectively. We can test whether these values are also consistent with a negligible Δ_0 bowing in InAs_{1-x}Sb_x by interpolating to find the expected pentenary values, P. We do this by treating these samples as a mixture of two quaternary alloys: $Q_1 = \text{GaAs}_{1-v-x} P_v \text{Sb}_x$ and $Q_2 = \text{InAs}_{1-v-x} P_v \text{Sb}_x$. We use the interpolation formula described by Krijn²² to calculate these and then interpolate between them using $P=zQ_1+(1-z)Q_2$ -z(1-z)C', where z is the gallium content and C'=(1-y)C' $-x)C_{InGaAs}+yC_{InGaP}+xC_{InGaSb}$. Using parameters from Ref. 10 and including the value C_{InGaSb} = +1170 meV of Berolo and Woolley¹¹ would give $\Delta_0 = 293 \pm 20$ and 286 ± 20 meV for s922 and s923, respectively, where the errors arise from the compositional uncertainties of the pentenary alloys. These predicted values are very much lower than our measured values. However, a zero bowing, $C_{InGaSb}=0$ meV, yields 415 and 420 meV, respectively, much closer to our measurements. This is further evidence that Δ_0 exhibits negligible positive bowing in $InAs_{1-x}Sb_x$. Note that our tentative fitted bowing of C_{InGaSb} =-225 meV predicts $\Delta_0(s922)$ =438 meV and $\Delta_0(s923)$ =446 meV, equal to the corresponding measurements within the aforementioned uncertainties.

To put our results into context, we can consider their impact on predicting Auger recombination rates in, say, a cryogenically cooled $InAs_{1-x}Sb_x$ based device for CO₂ gas detection at 4.25 μ m ($E_0 \sim 290$ meV), which from Fig. 2(a) would be provided by an Sb molar fraction of ~17%. Currently accepted literature results would predict $\Delta_0 \sim 295$ meV,^{10,11} within 5 meV of E_0 . Such a resonance, $E_0 \approx \Delta_0$ would result in very high CHSH Auger losses, since near-vertical transitions could occur between states close to the band edges.³ However, using our result of negligible bowing gives $\Delta_0 \sim 460$ meV, which, since $\Delta_0 \gg E_0$ would predict that the CHSH process is no longer of importance compared to the other processes.³ Therefore, theoretical predictions of the performance of such a device would differ

greatly in terms of the extent of the different Auger losses, depending on which value for Δ_0 was used.

In the future we hope to extend these PR studies to even longer wavelengths, in order to quantify $C(\Delta_0)$ in $InAs_{1-x}Sb_x$ samples containing higher antimony fractions.

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